

OSTROLENK, FABER, GERB & SOFFEN, LLP

Attorneys at Law 1180 Avenue of the Americas

New York, New York 10036-8403

Tel (212) 382-0700 Fax (212) 382-0888 email@ostrolenk.com

Express Mail # EV 342532706 US

Mail Stop Patent Application Commissioner for Patents P.O. Box 1450 Alexandria, VA 22313-1450

OFGS File No.: P/2850-90

Inventor

: Tomoko TAKAGI et al.

Title

: THIN FILM DEPOSITING METHOD AND APPATATUS

Assignee

: Ishikawajima-Harima Heavy Industries Co., Ltd.

Enclosed herewith please find the following documents in the above-identified application for United States Letters Patent:

In the event the actual fee is greater than the payment submitted or is inadvertently not enclosed, or if any additional fee during the prosecution of this case is not paid, the Patent and Trademark Office is authorized to charge the underpayment to Deposit Account No. 15-0700.

EXPRESS MAIL CERTIFICATE

I hereby certify that this correspondence is being deposited with the United States Postal Service as Express Mail Post Office to Addressee (mail label #EV 342532706 US) in an envelope addressed to: Mail Stop Patent Application, Commissioner for Patents, P.O. Box 1450, Alexandria, VA 22313-1450, on December 1, 2003:

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December 1/2003

Date of Signature

Respectfully submitted,

Robert C. Faber

Registration No.: 24,322

OSTROLENK, FABER, GERB & SOFFEN, LLP

1180 Avenue of the Americas

New York, New York 10036-8403

Telephone: (212) 382-0700